



PATENT
Customer No. 22,852
Attorney Docket No. 08244.0032

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Sung-Chan PARK et al.) Group Art Unit: 2813
Application No.: 09/998,303) Examiner: Nguyen, Thanh T.
Filed: December 3, 2001)
For: METHOD FOR FORMING)
CONTACT HOLE AND SPACER)
OF SEMICONDUCTOR DEVICE)

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FEB 23 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

RESPONSE AND REQUEST FOR RECONSIDERATION

In reply to the Final Office Action of November 19, 2003, Applicants request reconsideration of the subject application for the reasons set forth below in the Remarks section.

Remarks begin on page 2 of this paper.

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